

2018 IEEE Electron Devices Technology
and Manufacturing Conference (EDTM2018)

July. 28th 2017

Name: 2018 IEEE Electron Devices Technology and Manufacturing Conference
(EDTM 2018)

Sponsored by: IEEE Electron Devices Society (EDS)

Date: March 13th (Tue.)– 16th (Fri.), 2018.

Venue: Ariston Hotel Kobe/The Kobe Chamber of Commerce and Industry
(Minatojimanakamachi 6-1 Chuo-ku Kobe-shi, Hyogo, Japan)

Mission of EDTM 2018:

EDTM is intended to serve as a forum for the electron devices community to collaborate on topics ranging from devices, materials, tools, packaging and manufacturing to create new and innovative technologies.

Conference Outline

(1) Program

Mar. 13th (Tue.): Tutorials, Short Courses, Cruise dinner (paid members only)

Mar. 14th (Wed.): Keynote speech, General lecture, Reception

Mar. 15th (Thu.): General lecture, Poster session, Networking event (tentative)

Mar. 16th (Fri.): General lecture, Poster session

(2) Countries, regions

20 countries/regions (China, European countries, India, Japan, Korea,
Singapore, Taiwan, USA, and more)

(3) Expected number of attendees

Japan about 200 people

Overseas about 200 people

Total about 400 attendees

(4) Official Language :English

Conference Background :

IEEE Electron Devices Technology and Manufacturing Conference is fully sponsored by the IEEE Electron Devices Society (EDS). 2nd EDTM conference is a full four-day conference to be held at Ariston Hotel Kobe/The Kobe Chamber of Commerce and Industry from March 13th to 16th, 2018.

Contact :

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